

Notice of References Cited	Application/Control No. 10/523,373		Applicant(s)/Patent Under Reexamination KIEFER ET AL.	
	Examiner Michael Bernshteyn		Art Unit 1713	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0062969	04-2004	Sakaguchi et al.	429/033
	B	US-			
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	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*	N	WO 02038650 B1	05-2002	WIPO	SAKAGUCHI et al.	
*	O	EP 1354907 A1	10-2003	European Patent	SAKAGUCHI et al.	
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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